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PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Andreas et al.

Serial No.: 10/645,710

Filed: August 21, 2003

For: WAFER CLEANING METHOD AND
RESULTING WAFER

Confirmation No.: 8457

Examiner: Tu Tu V. Ho

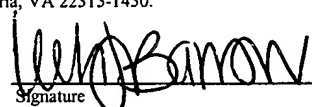
Group Art Unit: 2818

Attorney Docket No.: 2269-5663US
(02-1325.00/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

November 30, 2004
Date


Signature

Leah J. Barrow
Name (Type/Print)

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are filed in response to the Examiner's remarks in the Office Action mailed August 31, 2004, the three-month shortened statutory period for response to which expires on November 30, 2004.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.